



Docket No.: 67161-124

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

International Application of

Hiroshi TANAKA

Serial No.: 10/690,565

Filed: October 23, 2003

: Customer Number: 20277

: Confirmation Number: 5966

: Group Art Unit: 1746

: Examiner: Unknown

For: A SUBSTRATE CLEANING DEVICE AND A METHOD FOR MANUFACTURING
ELECTRONIC DEVICES

REQUEST FOR CORRECTED FILING RECEIPT

Mail Stop OFR
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a copy of the Filing Receipt received from the U.S. Patent and Trademark Office in the above-referenced application. It is noted that the Foreign Application information is incorrect. Attached is a copy of the Declaration and Attorney Document, which evidences that the correct Foreign Application information should read: **JAPAN 2003-100703(P) 04/03/2003**. It is requested that a corrected filing receipt be issued.

Respectfully submitted,

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/690,565	10/23/2003	1746	770	67161-124	5	8	2

CONFIRMATION NO. 5966

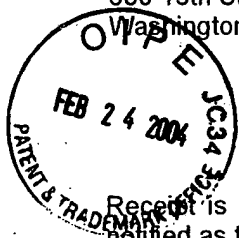
FILING RECEIPT



OC000000011734929

Date Mailed: 01/22/2004

McDermott, Will & Emery
 600 13th Street, N.W.
 Washington, DC 20005-3098



Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

RENESAS TECHNOLOGY CORP.;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2003-1000703(P) 04/03/2003
 100703(CP)

If Required, Foreign Filing License Granted: 01/21/2004

Projected Publication Date: 10/07/2004

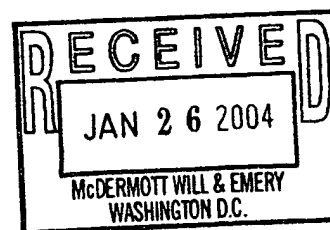
Non-Publication Request: No

Early Publication Request: No

Title

Substrate cleaning device and a method for manufacturing electronic devices

Preliminary Class



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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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